

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Chu-Jung SHIH et al.)	Group Art Unit: 2812
)	
Application No.: 10/796,343)	Examiner: Ghyka, Alexander G.
)	
Filed: March 10, 2004)	Confirmation No. 1988
)	
For: METHOD FOR REDUCING)	
SURFACE ROUGHNESS OF)	
POLYSILICON FILMS FOR)	
LIQUID CRYSTAL DISPLAYS)	

Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT

In reply to the Office Action of May 4, 2005, the period for response to which extends through August 4, 2005, Applicants respectfully request reconsideration in view of the following remarks.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks follow the **Amendments to the Claims** section of this paper beginning on page 5 of this paper.